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Uri Cohen, Applicant

June 7, 2007
Date of Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Uri Cohen Confirmation No. 2289
Serial No.: 10/688,333 Filed: 10/17/2003
Grp. Art Unit: 1742 Examiner: Wilkins III, Harry D.
Title of Application: Method and Apparatus for Activating Openings for Jets Plating

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

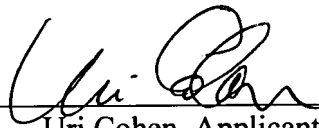
S I R:

Information Disclosure Statement under 37 CFR 1.98

Applicant respectfully requests that the reference listed on the attached form PTO-1449 be considered in the examination of the above-identified application. The listing on the form PTO-1449 shall not be construed as a representation that this reference is a prior art or that no other art than that identified exists. A check for \$180 for the IDS Fee is enclosed herein.

Respectfully submitted,

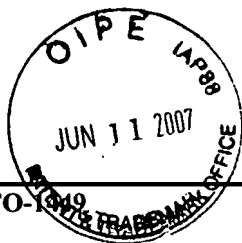
Dated: June 7, 2007

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PTO/SB/08 (10-92)
Sheet 1 of 1.

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| FORM PTO-1049 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary) | Docket Number (Optional): JETS-02 | Application Number: 10/688,333 |
| | Applicant: Uri Cohen | Examiner: Wilkins III, Harry D. |
| | Filing Date: 10/17/2003 | Group Art Unit: 1742 |

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
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FOREIGN PATENT DOCUMENTS

| DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation YES NO |
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NON-PATENT LITERATURE DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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| | | "Silicon Epitaxial Growth by Electrodeposition from Molten Fluorides" by U. Cohen et al., in Journal of The Electrochemical Society, Vol. 123(3), pp. 381-383, March 1976. |
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| EXAMINER | DATE CONSIDERED |
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

PTO/SB/08 (10-92)

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